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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.		
08/808,315	02/28/1997	HIROYUKI KINOSHITA	247/PD-5385	6175		
7	590 10/20/2003	EXAMINER				
JOHN P. SCI	HERLACHER, ESQ.	MENEFEE, JAMES A				
HOGAN & HA	ARTSON, L.L.P					
500 SOUTH GRAND AVENUE, SUITE 1900			ART UŅIT	PAPER NUMBER		
BILTMORE TOWER			2828	2828		

DATE MAILED: 10/20/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

		,					IM /	
	٠,		Applicatio	n No.		Applicant(s)	WV	
			08/808,31	5		KINOSHITA ET AL.		
		Office Action Summary	Examiner			Art Unit		
		James A. N			2828			
Peri		The MAILING DATE of this communication ap r Reply	pears on the	cover	sheet with the	correspondence a	address	
- - -	Exter after If the If NO Failur Any rearne	ORTENED STATUTORY PERIOD FOR REPL MAILING DATE OF THIS COMMUNICATION. Insions of time may be available under the provisions of 37 CFR 1. SIX (6) MONTHS from the mailing date of this communication. Period for reply specified above is less than thirty (30) days, a represent of the reply is specified above, the maximum statutory period the to reply within the set or extended period for reply will, by statutely received by the Office later than three months after the mailing dispatent term adjustment. See 37 CFR 1.704(b).	136(a). In no ever ply within the statu I will apply and will te, cause the appli	nt, howe tory mini expire S cation to	ver, may a reply be mum of thirty (30) d SIX (6) MONTHS fro become ABANDON	timely filed  ays will be considered tin in the mailing date of this NED (35 U.S.C. § 133).	nely. communication.	
1	1)⊠	Responsive to communication(s) filed on 17	September 2	<u>2003</u> .				
2a	a) 🗌	This action is <b>FINAL</b> . 2b)⊠ TI	his action is i	non-fir	nal.			
	3)□ ositi	Since this application is in condition for allow closed in accordance with the practice under on of Claims					the merits is	
		Claim(s) 20-22 is/are pending in the application	ion.	•				
	, —	4a) Of the above claim(s) is/are withdra	awn from con	sidera	ation.	0	0	
5	5)	Claim(s) is/are allowed.				Pan	D	
$\epsilon$	S)⊠	Claim(s) <u>20-22</u> is/are rejected.				PAUL	IP	
7	7)	Claim(s) is/are objected to.				SUPERVISORY PAT	ent examiner	
	•	Claim(s) are subject to restriction and/o	or election re	quirer	nent.	TECHNOLOGY C	enter 2800	
		on Papers						
	•	The specification is objected to by the Examine						
10	))[_] [	The drawing(s) filed on is/are: a)□ acce	, ,—	•	•			
4.4	\[	Applicant may not request that any objection to the						
11	י נבוני	The proposed drawing correction filed on  If approved, corrected drawings are required in re				roved by the Exam	iner.	
12	ר רווי	The oath or declaration is objected to by the Ex	• •	ce aci	on.			
		nder 35 U.S.C. §§ 119 and 120	жини.					
	_	Acknowledgment is made of a claim for foreig	ın nriority und	ler 35	USC 8 119	(a)-(d) or (f)		
	•	☑ All b)☐ Some * c)☐ None of:	in phoney and	ici 00	0.0.0.3 110	(a) (a) 51 (1).		
	عرب	1. ☐ Certified copies of the priority document	its have been	recei	ved.			
		2. ☐ Certified copies of the priority document				ition No.		
		Copies of the certified copies of the prior application from the International Bure the attached detailed Office action for a list	ority documer ureau (PCT F	nts ha Rule 1	ve been recei 7.2(a)).	ved in this Nationa	al Stage	
14)		cknowledgment is made of a claim for domest					al application).	
	a)	☐ The translation of the foreign language process	ovisional app	licatio	on has been re	eceived.	,	
	hment	<del>-</del>	p. 101119 WII					
2) 🔲	Notice	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449) Paper No(s)		5) 🔲		rry (PTO-413) Paper N I Patent Application (F		

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#### **DETAILED ACTION**

## Response to Amendment

This action is in response to the applicant's response filed 17 September 2003. The claims were not amended. Claims 20-22 are pending.

### Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

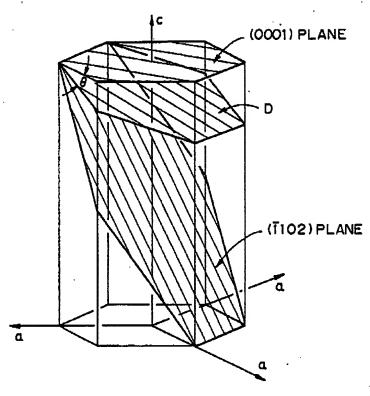
(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 20-21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hosoi et al. (previously cited US 4,908,074) in view of Setsune (previously cited JP 61121042), and further in view of Iwasaki et al. (US 5,549,978).

Regarding claim 20, Hosoi discloses a sapphire monocrystal plate comprising a sapphire monocrystal having a major face, wherein the major face is a plane A or a plane C of the sapphire monocrystal (see Fig. 3 marked up below and discussion thereof, and col. 6 lines 55-66). It is not disclosed that there is a working reference plane on a peripheral edge of the plate that is substantially perpendicular or parallel to a plane R of the sapphire monocrystal. Setsune teaches that it is known to cleave an R plane of a sapphire monocrystal. It would have been obvious to one skilled in the art to cleave a sapphire monocrystal, such as that found in Hosoi Fig. 3, along the R plane as in Setsune, in order to form certain devices that require such a cleaving, such as Setsune's optical switch, as taught by Setsune. After such an obvious cleavage

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of the R plane, the edge of the plate will be the R plane, and will be a working reference plane on the peripheral edge of the plate.



Hosoi, Fig. 3

It is further not disclosed that the major surface, i.e. the C plane of Hosoi Fig. 3, has a surface roughness of less than 0.1 microns. Iwasaki discloses that a C plane of a sapphire crystal may be polished to a surface roughness less than 0.1 microns (col. 24 lines 45-51). It would have been obvious to one skilled in the art to do this so that the plane may be a mirror surface, as taught by Iwasaki. There are numerous applications known in the art where a plane of a sapphire crystal is formed as a mirror.

Regarding claim 21, the working reference plane is the R plane, and thus the angle therebetween is 0 degrees.

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Claims 22 is rejected under 35 U.S.C. 103(a) as being unpatentable over Hosoi and Setsune and Iwaskai as applied to claims 20-21 above, and further in view of Nitta et al. (US 5,403,773). The limitations of claims 20-21 are taught as above, but there is not disclosed a microcrack line on the major face parallel to the plane R for starting to cleave the plate. Nitta teaches that a wafer is scribed along cleavage lines (col. 3 lines 37-43). This scribing will inherently form a microcrack, as scribing by definition entails scratching a wafer to form a crack. Since it was shown above to be obvious to cleave along the R plane, then the microcrack formed by such scribing will necessarily be parallel to the R plane. It would have been obvious to one skilled in the art to scribe the device in order to perform the cleaving process, as taught by Nitta.

### Response to Arguments

Applicant's arguments with respect to the claims have been considered but are moot in view of the new ground(s) of rejection. The applicant is claiming nothing more than a sapphire body having a face that is a C or A plane and an edge that is an R plane or parallel to an R plane, where the C or A plane has the specified roughness. All sapphire crystals will, by definition, include C, A, and R planes. It is shown herein that the faces and edges of a sapphire crystal may be as claimed.

#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to James A. Menefee whose telephone number is (703) 605-4367. The examiner can normally be reached on M-F 8:30-5.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Paul Ip can be reached on (703) 308-3098. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

JM

October 8, 2003

PAUL IP

SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800